



Dkt. No. 55220/844

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Shoji Miyazaki et al.

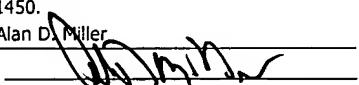
Appl. No. : 10/809,217

Filed : March 25, 2004

For : BIOSENSOR, THIN FILM ELECTRODE FORMING METHOD,
QUANTIFICATION APPARATUS, AND QUANTIFICATION
METHOD

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Art Unit : 1795 I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail" service under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Confirmation No.: 6571 Name: Alan D. Miller
Signature: 

Examiner : Alexander Stephan Noguerola

**AMENDMENT AND SUPPLEMENTAL INFORMATION DISCLOSURE
STATEMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**

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P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A Notice of Allowance issued in the above-identified application on June 14, 2010. The issue and publication fees have not yet been paid. Payment of the fees is due by September 14, 2010. Accordingly, this Request for Continued Examination (37 C.F.R. §1.114) and accompanying Amendment and Supplemental Information Disclosure Statement are being timely filed.